

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: **S. SHIRAYONE, et al.**

Application No.: **10/791,856**

Filed: **MARCH 4, 2004**

For: **METHOD FOR PROCESSING PLASMA PROCESSING APPARATUS**

Group AU: **1792**

Examiner: **Stephen K. Ko**

Confirm. No.: **5252**

AMENDMENT

Mail Stop: AMEND - FEE

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

May 22, 2009

SIR:

In response to the Office Action mailed January 23, 2009, the period for response having been extended for one (1) month by the attached Petition for Extension of Time, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.